

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.	: 10/550,459	Confirmation No.	: 4620
First Named Inventor	: Decams, Jean-Manuel		
Filed	: December 12, 2006		
TC/A.U.	: 1792		
Examiner	: Michael G. Miller		
Docket No.	: 104003.B130130		
Customer No.	: 23911		
Title	: Method for CVD Deposition of a Silver Film on a Substrate		

AMENDMENT AND RESPONSE UNDER 37 C.F.R. § 1.111

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In complete response to the non-final Office Action dated April 4, 2008, Applicants submit herewith a Petition for a three month extension of time, extending the period of response from July 4, 2008 to October 4, 2008, and the following Response.

Amendments to the Claims are reflected in the Listing of Claims, which begins on page 2 of this Response.

Remarks begin on page 4 of this Response.